



Patent
Attorney's Docket No. 1003510-000164

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| In re Patent Application of |) MAIL STOP AMENDMENT |
| Masafumi MIYAKAWA et al. |) |
| Application No.: 10/507,245 |) Group Art Unit: 1711 |
| Filed: September 10, 2004 |) Examiner: JEFFREY C MULLIS |
| For: PRESSURE-SENSITIVE ADHESIVE |) Confirmation No.: 9077 |
| FILM FOR THE SUFACE PROTECTION |) |
| OF SEMICONDUCTOR WAFERS AND |) |
| METHOD FOR PROTECTION OF |) |
| SEMICONDUCTOR WAFERS WITH |) |
| THE FILM |) |

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated November 18, 2005, please amend the
above-identified patent application as follows: